

1       **Design and fabrication of effective gradient temperature sensor**  
2       **array based on bilayer SnO<sub>2</sub>/Pt for gas classification**

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1 **Abstract:**

2 Classification of different gases is important and it is possible to use different gas sensors for this  
3 purpose. Electronic noses, for example, combine separated gas sensors into an array for detecting  
4 different gases. However, the use of separated sensors in an array suffers from being bulky, high  
5 energy consumption and complex fabrication processes. Generally, gas sensing properties,  
6 including gas selectivity, of semiconductor gas sensors are strongly dependent on their working  
7 temperature. It is therefore feasible to use a single device composed of identical sensors arranged  
8 in a temperature gradient for classification of multiple gases. Herein, we introduce a design for  
9 simple fabrication of gas sensor array based on bilayer Pt/SnO<sub>2</sub> for real-time monitoring and  
10 classification of multiple gases. The study includes design simulation of the sensor array to find  
11 an effective gradient temperature, fabrication of the sensors and test of their performance. The  
12 array, composed of five sensors, was fabricated on a glass substrate without the need of backside  
13 etching to reduce heat loss. A SnO<sub>2</sub> thin film sensitized with Pt on top deposited by sputtering  
14 was used as sensing material. The sensor array was tested against different gases including  
15 ethanol, methanol, isopropanol, acetone, ammonia, and hydrogen. Radar plots and principal  
16 component analysis were used to visualize the distinction of the tested gases and to enable  
17 effective classification.

18 **Keywords:** design of sensor array; electronic nose; gradient temperature; gas classification

19

## 1 **1. Introduction**

2 Gas sensors have many applications, including air pollution monitoring, gas leakage detection,  
3 industrial process optimization and control, and breath analysis [1,2] [3–5]. Resistive metal oxide  
4 semiconductor gas sensors have the advantages of being small size, low cost, portability and  
5 robustness [1,2]. For example, it was reported that a metal oxide-based gas sensor with  
6 extremely low power consumption could be connected to the "Internet of Things" with a tiny  
7 chip for disease diagnosis and patient monitoring [6]. However, a single gas sensor device is not  
8 capable to selectively recognize different gases in a mixture [1,2] [7]. Electronic noses and/or  
9 multiple sensors are important in practical applications, such as food and beverage industry,  
10 agriculture and forestry, medicine and healthcare, indoor and outdoor monitoring, military and  
11 civilian security [8] [9]. An electronic nose employing 14 conducting polymers based on  
12 polyaniline was used to diagnose tuberculosis, where the specificity of the described method was  
13 91% [10]. Zhang et al. [11] used an array of four separated sensors for detection of acetone,  
14 benzene, methanol and formaldehyde. Chen et al. [12] used an array of gas sensors together with  
15 algorithms employed in artificial olfactory systems to explore their potential applications in  
16 disease diagnosis, environmental monitoring and explosive detection. Güntner et al. [13] used an  
17 array of four sensors composed of nanostructured sensing films of highly porous SnO<sub>2</sub> doped  
18 with Pt, Si, Pd, and Ti, for quantification of breath-relevant formaldehyde levels. Zhang et al.  
19 [14] used an array of six commercial sensors and an artificial neural network for detection of  
20 mixed indoor hazardous gases. An array of commercial sensors is bulky and consumes much  
21 energy [15] [16]. It is well-known that metal oxide gas sensors exhibit different trends in  
22 response to various gases at different temperatures depending on the sensing material [17] [18].  
23 Barsan et al. reported that SnO<sub>2</sub> based sensor showed different trends in response to various

1 gases at different temperatures with an interval of 50 °C. Based on the working principle of the  
2 sensors in temperature gradient, several works have been reported on fabrication of electronic  
3 noses using a single sensing material [20]. Tonezzer et al. [21] reported the possibility of using  
4 response values at different temperatures from a sensor based on Pt-SnO<sub>2</sub> nanowires, to classify  
5 benzene, acetone, hydrogen, toluene, and ethanol via machine learning techniques. Another  
6 electronic nose that used a single material (SnO<sub>2</sub> nanowires) decorated with different metallic  
7 nanoparticles was reported as an effective device for classification of three reducing gases (H<sub>2</sub>,  
8 CO, and ethylene) [22]. Yet another electronic nose based on ZnO nanowires, ZnO–ZnAl<sub>2</sub>O<sub>4</sub>  
9 core–shell nanowires and ZnO–Zn<sub>2</sub>TiO<sub>4</sub> core–shell nanowires operated under UV illumination  
10 was reported that it could discriminate CO, O<sub>2</sub>, NO<sub>2</sub>, and O<sub>3</sub> gases [23]. An array of sensors  
11 based on a single SnO<sub>2</sub> nanobelt decorated with Pd nanoparticles could classify ethanol,  
12 isopropyl alcohol, toluene and CO [20] using back-side microheaters to create a temperature  
13 gradient for the different sensors. The use of the back-side microheaters required complex  
14 fabrication processes [26,27] and therefore was not cost effective for the application [24].  
15 Temperature gradient method was known to be simple and cost effective since a single device  
16 composed of an array of sensors with the same sensing material could be used for classification  
17 of different gases in a gas mixture [25]. Sysoev et al. used two microheaters to obtain a  
18 temperature gradient span of 80 K (from 520–600 K) across the chip [25]. However, the small  
19 temperature increments between the electrodes, together with the inhomogeneous distribution of  
20 the SnO<sub>2</sub> nanowire as sensing material between them, limited the sensor application. Generally,  
21 for practical applications, designs of sensor arrays with simple fabrication processes and  
22 effective temperature gradient is practically important [28].

1 Here, a sensor array based on a bilayer Pt/SnO<sub>2</sub> thin film with effective temperature gradient in  
2 the range of 200 to 400 °C is introduced for gas classification. The design of the sensor was  
3 iteratively simulated and the fabrication was performed using conventional photolithography thin  
4 film deposition and lift-off. ~~The sensor array within the temperature gradient enables the device~~  
5 ~~to operate as an electronic nose for gas classification. The advantages of our sensor array include~~  
6 ~~small size, rapidity, stability, portability, and robustness.~~

## 7 **2. Experimental**

### 8 **2.1 Design of sensor array**

9 To design the sensor array with effective temperature gradient the COMSOL Multiphysics 5.4  
10 software (COMSOL Inc., Burlington, MA, USA) was used to simulate the thermal distribution.  
11 The design is shown in Figure 1(A), which includes five sensors denoted as S1, S2, S3, S4 and  
12 S5. The sensor chip was fabricated on a glass substrate with dimensions of 6×6 mm<sup>2</sup> and  
13 thickness of 0.5 mm. The microheater segments were of the same length but different widths,  
14 with heat sinks of the same dimensions in between. In simulation, constrains for Joule heating,  
15 thermal radiation and heat transfer in solid were applied. The variables were temperature ( $T$ ) and  
16 resistance ( $R$ ) or voltage ( $V$ ). The dependency of a microheater resistance on the temperature can  
17 be expressed as:

$$18 \quad R = \frac{\rho L}{wt} \quad (1.1)$$

$$19 \quad \frac{1}{\rho} = \sigma = \frac{\sigma_0}{1+\alpha(T-T_0)} \quad (1.2)$$

20 Where  $\rho$  is the resistivity of the material,  $\sigma$  is the conductivity of the material,  $L$ ,  $w$  and  $t$  are the  
21 length, width and thickness of the microheater, respectively,  $\alpha$  is the coefficient of heat  
22 resistance,  $\rho_0$  is the electrical resistivity at  $T_0$ . The mathematical model for the heat transfer is  
23 expressed by the equation:

1 
$$\delta C_p \frac{\partial T}{\partial t} - \Delta(k\Delta T) = Q \quad (1.3)$$

2 where  $\delta$  is density of the microheater material,  $C_p$  is its specific heat,  $k$  is its coefficient of  
 3 thermal conductivity and  $Q$  is the heat generated by the electric current flowing through the  
 4 resistive heater.  $Q$  is proportional to the square of the current density  $J$ , and is called Joule  
 5 heating:

6 
$$Q \propto |J|^2 = \rho |J|^2 = \frac{1}{\sigma} |J|^2 \quad (1.4)$$

7 or

8 
$$Q = \sigma |\nabla V|^2 \quad (1.5)$$

9 where  $\sigma$  is the conductivity of the microheater and  $V$  is the applied voltage.

10 The power consumption of the microheater is calculated by the equation

11 
$$P = \frac{V^2}{R} \quad (1.6)$$

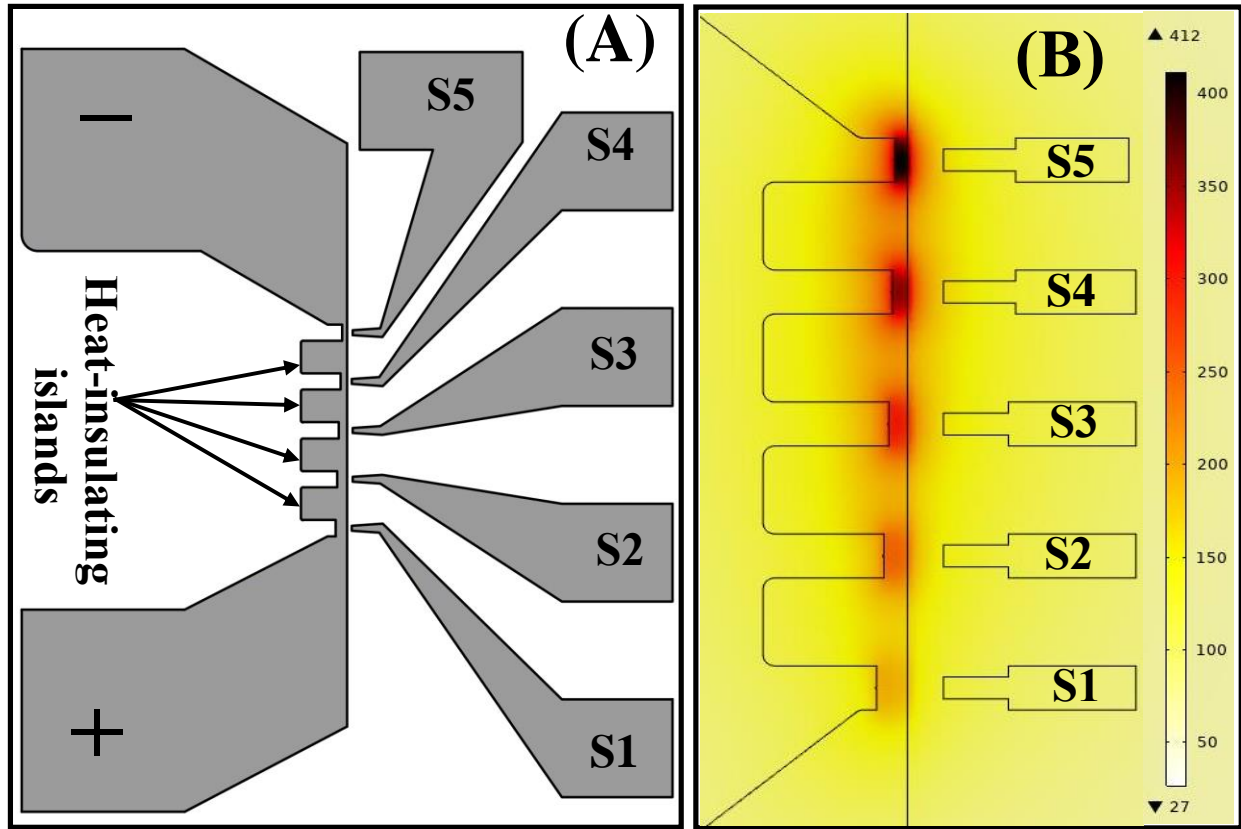
12 The input parameters for the simulation are summarized in Table 1, where Pt was used as  
 13 material of the microheater. By changing the widths of the microheater segments iteratively  
 14 design of a sensor array with temperature gradient from 200 °C to 400 °C with an increment of  
 15 about 50 °C for each sensor was obtained, as shown in Figure 1(B). The simulated sensor  
 16 configuration and microheater dimensions were then used for the fabrication of the real device.

17

18 **Table 1.** Physical parameters of Pt microheater for simulation

heater	Dielectric	Conductivity	Coefficient of thermal	Heat capacity	Specific	Thermal	Modul	Coefficient
--------	------------	--------------	------------------------	---------------	----------	---------	-------	-------------

	constant		expansion	constant	weight	conductivity	Young	Poisson
		(S/m)	(1/K)	(J/kg*K)	(kg/m <sup>3</sup> )	(W/(m*K))	(Pa)	
Pt	1.27E-06 (0.08)- 0.6	8.90E+06	8.80E-06	133	21450	71.6	1.68E+11	0.38



1

2

**Figure 1.** (A) Design and (B) simulation result of heat distribution of the five sensors

3

## 2.2 Fabrication of the sensor array

4

The sensor array fabrication process using conventional photolithography are shown in Figure 2.

5

The steps for making the microheater and the electrodes include (1) spin coating of photoresist,

6

(2) UV light exposure and development and (3) deposition of Pt/Cr and (4) lift-off. The steps of

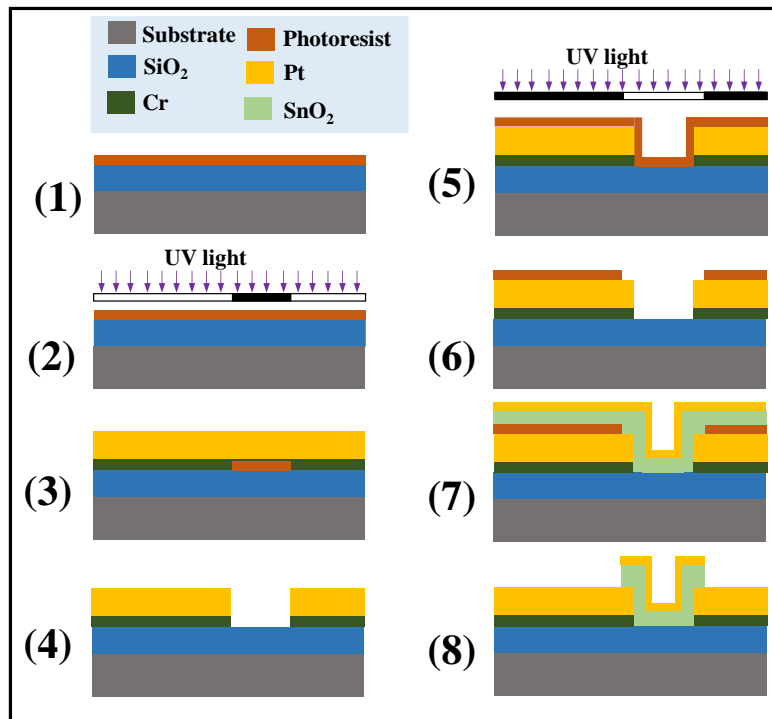
7

depositing sensing material include (5) to (8), which need no explanation. The thin film of the

8

sensing material SnO<sub>2</sub> with a thickness of 50 nm was reactively sputtered from a Sn target in a

1 Ar/O<sub>2</sub> gas mixture environment [29]. A thin layer of Pt with a thickness of 2 nm was then  
 2 deposited in the same sputtering system, but in only Ar environment. The base pressure and that  
 3 during the sputtering were 10<sup>-6</sup> and 10<sup>-3</sup> torr, respectively. The sputtering power was fixed at 30  
 4 W for deposition of both SnO<sub>2</sub> and Pt. The thicknesses of SnO<sub>2</sub> and Pt were optimized to  
 5 maximize the sensor response, as reported in [30].



6

7 **Figure 2.** Process steps for fabrication of the sensor array

8 **2.3 Sensor characterization**

9 For easy and safe handling of the sensor chip a special PCB for mounting it was fabricated. The  
 10 PCB with the sensor chip then was connected to an electrical characterization system. The  
 11 transient output voltage from each sensor was measured on a reference resistor ( $R_{ref.i}$ ) connected  
 12 in series with the sensor using a home-made data acquisition system (Figure S1, Supplementary).  
 13 Details about the data acquisition system can be found in [31]. By applying a voltage on the

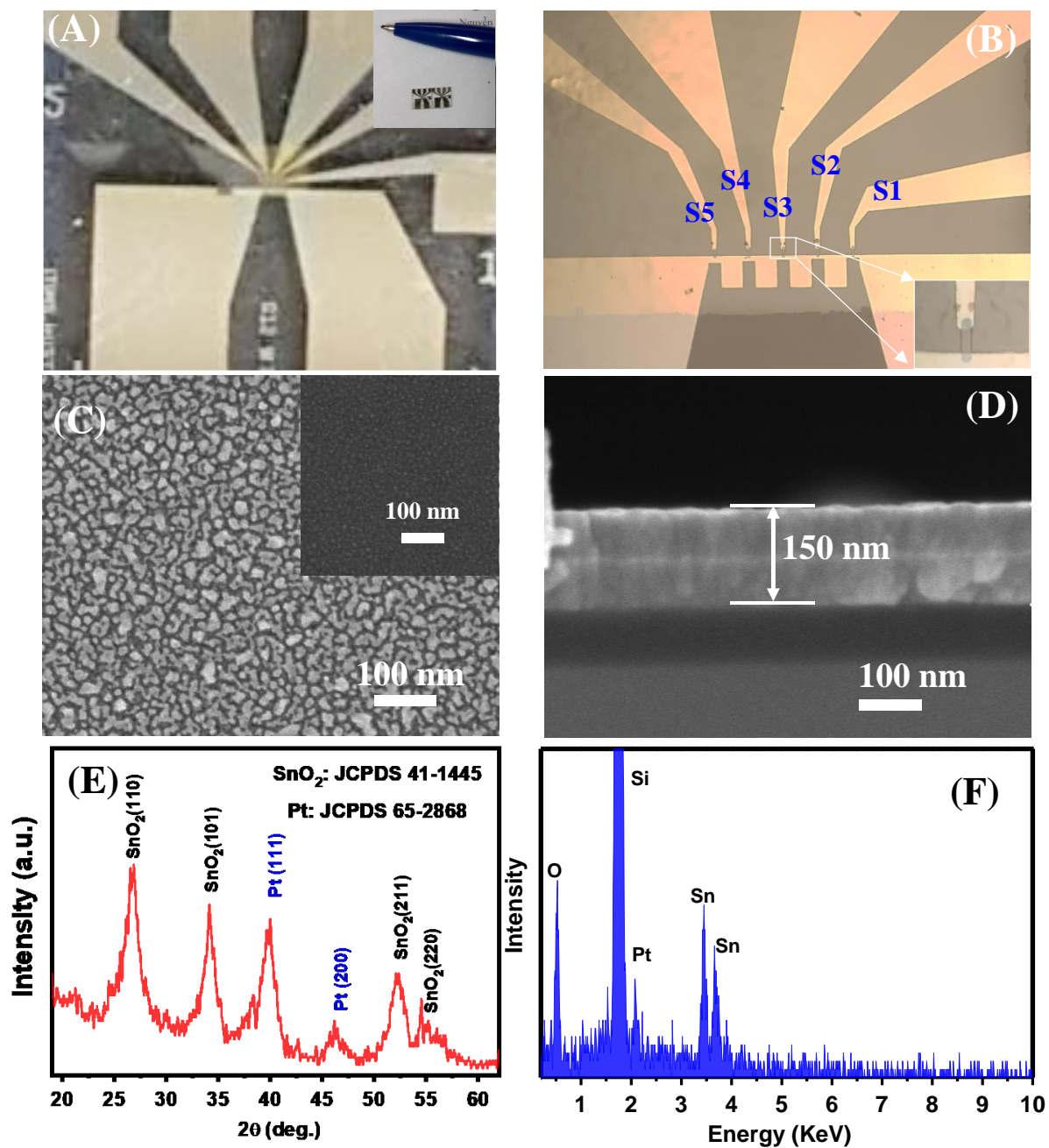


1 microheater, the power consumed by the sensor array could be calculated as  $P=V^2/R$ , where  $V$  is  
2 the applied voltage and  $R$  is the resistance of the microheater. For the thermal test, powers of 30,  
3 50, and 80 mW were applied and temperatures from each sensor were measured using an IR  
4 microscope (Thermovision A40, Flir system, USA), as shown in Figure 3. For the gas-sensing  
5 characterization, the atmosphere was switched from air to analytic gas and back to air while the  
6 output voltages from the five sensors were recorded by the data acquisition system and used to  
7 calculate the sensor responses. The sensor response of each sensor was defined as  $S=V_{gas}/V_{air}$ ,  
8 where  $V_{gas}$  and  $V_{air}$  were the voltage drop across its reference resistor in analytic gas and in air,  
9 respectively. Six gases were tested in the present study, namely ammonia, hydrogen, methanol,  
10 acetone, ethanol, and isopropanol (IPA).

### 11 **3. Results and discussion**

12 Optical microscopy photos of the fabricated sensor array are shown in Figure 3(A) and (B). The  
13 inset in Figure 3(A) is a photo of two sensor chips compared with the tip of a ballpoint pen. The  
14 size of the sensor chip is  $5\times 5$  mm<sup>2</sup>. Figure 3(B) shows the center part of a fabricated sensor chip.  
15 The five sensors were marked as S1, S2, S3, S4 and S5, consecutively. The inset in Figure 3(B)  
16 shows the sensing material of one sensor, with the size of approximately  $6\times 15$   $\mu$ m. A SEM  
17 image of the Pt/SnO<sub>2</sub> thin film is shown in Figure 3(C). The thin film surface includes many  
18 grains smaller than 20 nm, which are not present on the very smooth surface of the bare SnO<sub>2</sub>  
19 thin film (inset in Figure 3(C)). Thus, the grains can be attributed to the aggregation of the thin Pt  
20 film formed during the thermal treatment. The cross-section SEM image of the Pt/SnO<sub>2</sub> thin film  
21 confirms its thickness of about 150 nm (Figure 3(D)). In this study, the thickness Pt is only about  
22 2 nm, therefore it is difficult to distinguish the interface between the two layers in the cross-  
23 section SEM image. Nevertheless, XRD pattern of the Pt/SnO<sub>2</sub> thin film (Figure 3(E)) shows the

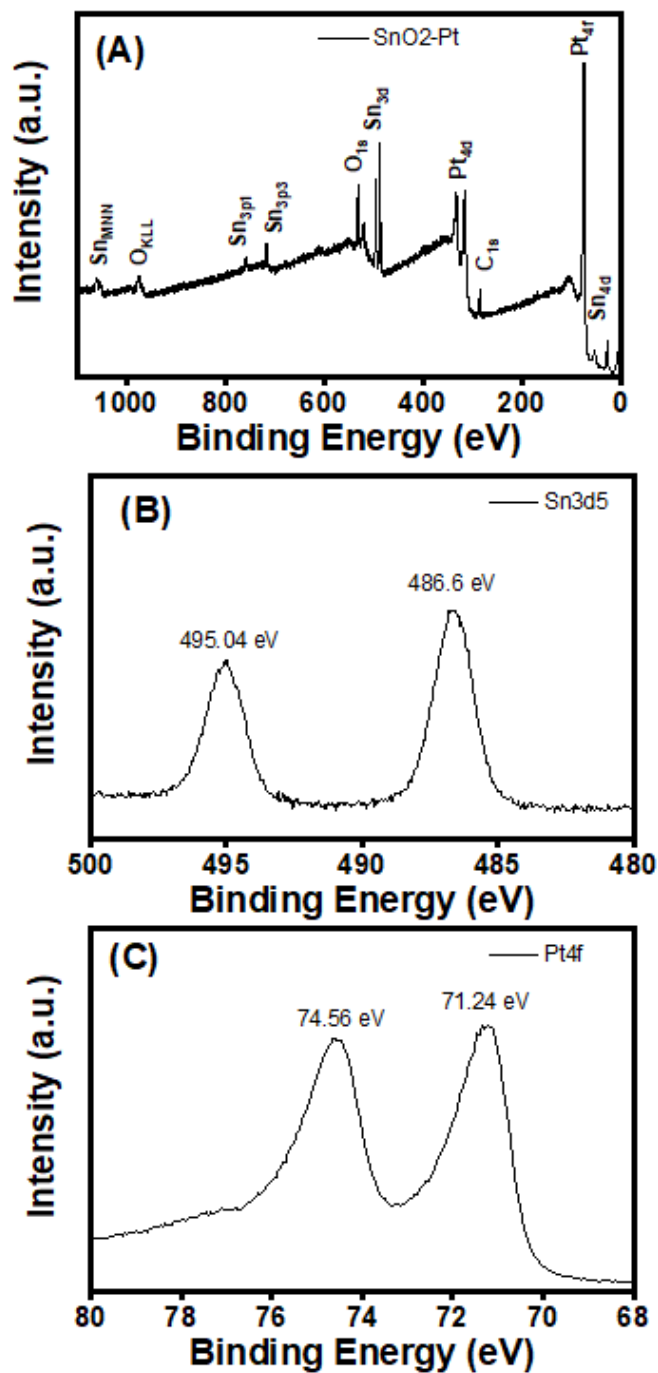
1 typical diffraction peaks of tetragonal SnO<sub>2</sub> (JCPDS No. 41-1445) and cubic Pt (JCPDS No. 65-  
2 2868) [32]. The decoration with metallic Pt on the surface of the SnO<sub>2</sub> thin film is very important  
3 for enhancing the gas sensing properties, for example toward hydrogen [33]. Notably, the  
4 intensity of the Pt peaks is relatively high because the Pt layer was deposited on top of the SnO<sub>2</sub>  
5 thin film. The SnO<sub>2</sub> diffraction peaks are very broad, indicating the nanocrystallinity of the  
6 fabricated thin film [34]. The average crystal size calculated by Scherrer equation using the (110)  
7 peak of SnO<sub>2</sub> is about 12 nm. The crystal size of SnO<sub>2</sub> is about twice its Debye length (~3.36  
8 nm) at operation temperature of about 250 °C, ensuring the high gas responsivity [35].  
9 Compared with the SnO<sub>2</sub> thin film sensor sensitized with microsized Pd islands in [34], the  
10 bilayer Pt/SnO<sub>2</sub> thin film has the advantage that it avoids the use of one mask in the fabrication  
11 process. EDS analysis of the Pt/SnO<sub>2</sub> thin film shown in Figure 3(F) confirms the presence of O,  
12 Sn, Pt elements. The peak of Si element in the EDS analysis comes from the silicon substrate.  
13 The elemental composition of different elements is 54.16, 44.60, 0.92 and 0.32 atom% for O, Si,  
14 Sn, and Pt, respectively. Since the content of Si and O comes from the substrate, the Pt/SnO<sub>2</sub> thin  
15 film composition estimated by EDS analysis is not expected to be quantitatively accurate.



1  
 2 **Figure 3.** (A) Optical microscopy image of the sensor chip. The inset shows two chips compared  
 3 with the tip of a ballpoint pen; (B) Optical microscopy image of the center part of the chip; (C)  
 4 Top-view SEM image of the Pt-decorated SnO<sub>2</sub> thin film. The inset shows a top-view SEM of  
 5 the bare SnO<sub>2</sub> film; (D) SEM image of the cross-section of the 150 nm SnO<sub>2</sub> and 2 nm Pt; (E)  
 6 XRD pattern of the Pt/SnO<sub>2</sub> thin film; and (D) EDS analysis of the Pt/SnO<sub>2</sub> thin film.

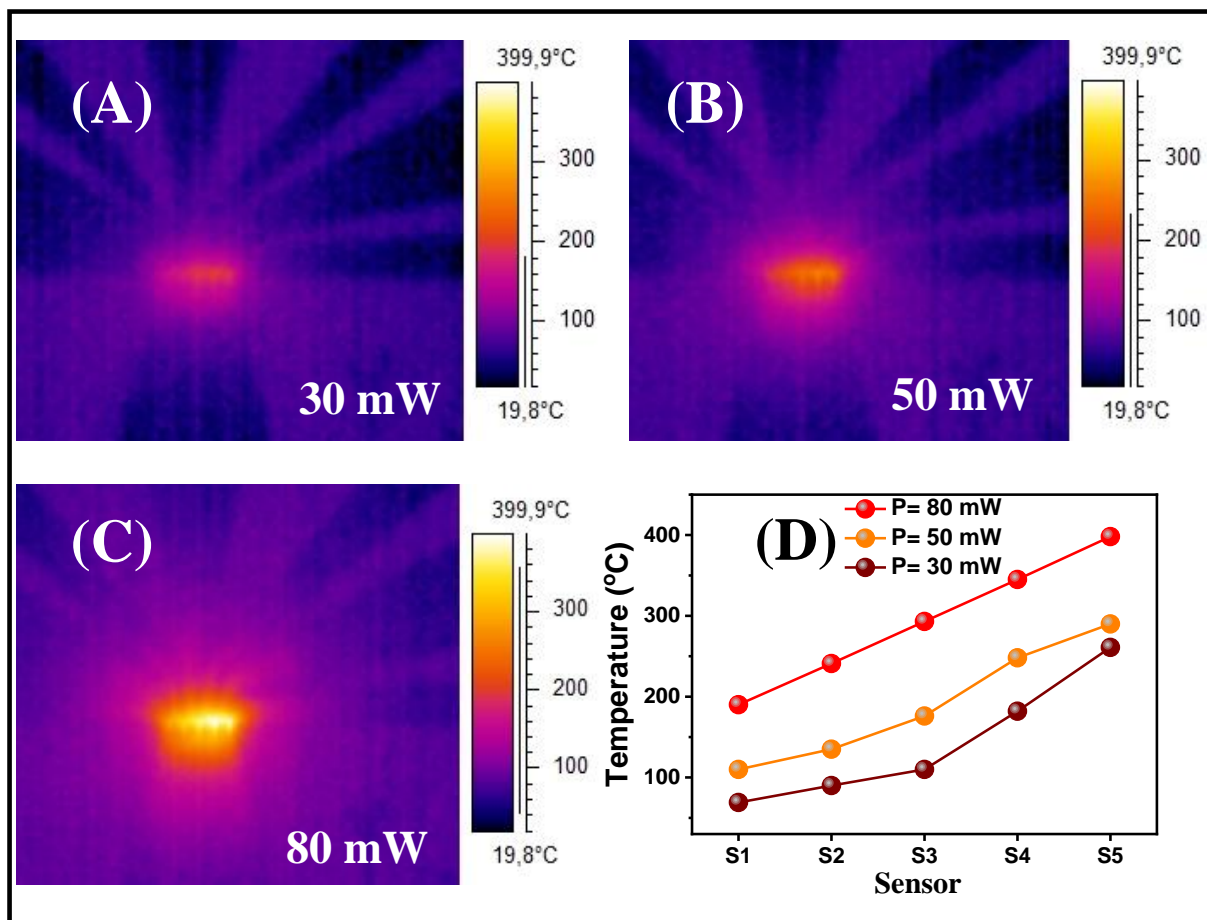
1 The Pt/SnO<sub>2</sub> thin film was further studied by XPS analysis, as shown in Figure 4. The survey  
2 scan of the thin film shown in Figure 4(A) reveals the presence of Sn, O, C and Pt, which is in  
3 consistency with the XPS database of SnO<sub>2</sub> and Pt. The atomic composition of the sample  
4 calculated from the XPS data is 42.4, 26.8, 23.2, 5.2 and 2.5% for O, Sn, C, Pt and N,  
5 respectively. An atomic ratio of [O]/[Sn]=1.58 is obtained, which confirms that the deposited  
6 SnO<sub>2</sub> is nonstoichiometric. The C1s peak of contamination carbon at 284.8 eV is used as the  
7 reference for other XPS peaks. Figure 4(B) is a high resolution scan of the Sn3d, which shows  
8 two peaks at 495.04 and 486.6 eV, attributed to the binding energies of Sn3d<sub>3/2</sub>, and Sn3d<sub>5/2</sub>,  
9 respectively. The binding energies of Sn3d<sub>3/2</sub> and Sn3d<sub>5/2</sub> peaks here are in consistency with  
10 those of Sn<sup>4+</sup> species, confirming the formation of SnO<sub>2</sub> in the thin film. The difference of the  
11 two binding energy peaks of Sn3d<sub>3/2</sub> and Sn3d<sub>5/2</sub> is 8.44 eV, in agreement with the reported  
12 literature, confirming the oxidation state of Sn(IV) [36]. The core-levels of Pt4f were also  
13 studied by high resolution XPS scan as shown in Figure 4(C). The two peaks with binding  
14 energies of 71.24 and 74.56 eV are attributed to Pt4f<sub>7/2</sub> and Pt4f<sub>5/2</sub> of Pt<sup>0</sup>, respectively [37,38].  
15 The results confirm that the Pt deposited on the surface of the SnO<sub>2</sub> thin film is in metallic and  
16 not oxide form. The presence of metallic Pt is desired for enhancement of the gas sensing  
17 performance due to the higher catalytic activity compared with the Pt oxide forms [36].

18



1  
 2 **Figure 4.** XPS analysis of the SnO<sub>2</sub>/Pt thin film: (A) survey scan; high-resolution scan of core-  
 3 levels (B) Sn<sub>3d</sub>; and (C) Pt<sub>4f</sub>.

1 Before testing the gas sensing performance of the sensor array, the temperature gradients from  
2 the micro heater at different applied powers was tested. As shown in Figure 5(A), (B) and (C),  
3 the infrared microscopy photos of the chip at applied powers of 30, 50, and 80 mW display the  
4 actual temperature gradients with interval of about 50 °C. Notably, in the metal oxide  
5 semiconductor based gas sensor, the device exhibits clearly different response trends with step of  
6 temperature gradient of about 50 °C [19]. The temperature plots of the S1–S5 sensors at applied  
7 powers of 30, 50 and 80 mW shown in Figure 5(D) document the actual temperature gradient  
8 from 69 to 398 °C. The results suggest that by using a single chip with five sensors and three  
9 applied powers, 15 data series of sensing signals in a single measurement can be generated. Of  
10 course the number of sensors and their simultaneous signals can be higher, as reported in the  
11 literature, for example ten sensors were used in a measurement system to classify gases via deep  
12 machine learning [39]. Here, the applied power is limited to 80 mW to prevent damage of the  
13 sensor and ensure its durability. As shown in Figure S2 ([Supplementary](#)), when a total power of  
14 90 mW is applied for 15 minutes, the S5 sensor heater is broken, making the whole sensor array  
15 unusable since the microheater segments are arranged in series. With the highest applied power  
16 of 80 mW, the temperatures of sensors S1, S2, S3, S4 and S5 are 190, 241, 293, 345 and 398 °C,  
17 respectively. The resulting temperature gradient is appropriate to make the five sensors behaving  
18 differently, as discussed latter.



1  
 2 **Figure 5.** IR images at (A)  $P = 30 \text{ mW}$ ; (B)  $P = 50 \text{ mW}$ ; (C)  $P = 80 \text{ mW}$ ; and (D) temperatures  
 3 of the five sensors at different powers

4 To evaluate the sensing performance of the sensor array, the response characteristics of the five  
 5 sensors to hydrogen at a power of 80 mW were first tested. Figure 6(A) shows the transient  
 6 response-recovery characteristics when periodically exposing the sensors to different  $\text{H}_2$   
 7 concentrations from 25 to 250 ppm. The response values  $S$  of all sensors increased significantly  
 8 with the increase of the  $\text{H}_2$  concentration. The increase of the responses against  $\text{H}_2$  gas confirms  
 9 that the  $\text{Pt}/\text{SnO}_2$  thin film has the n-type semiconducting characteristics [40]. For all five sensors,  
 10 the responses increase with the increase of  $\text{H}_2$  gas concentrations over the measured range,  
 11 indicating the non-saturation of the sensor and thus capability of effective application in

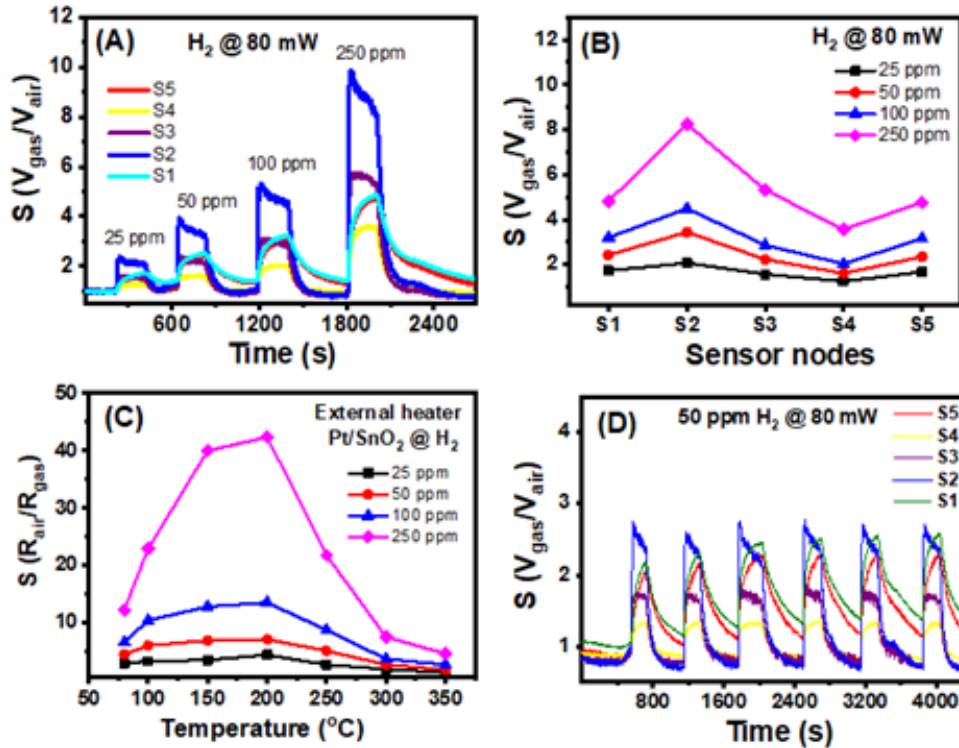
1 monitoring H<sub>2</sub> at wide range concentration. It is clear that at each H<sub>2</sub> concentration, the response  
2 and recovery characteristics improved from sensor S1 to sensor S5. This can be explained by the  
3 temperature increase from sensor S1 to sensor S5, accordingly. The responses of the five sensors  
4 to various H<sub>2</sub> concentrations are shown in Figure 6(B). The sensor S2 has the highest response  
5 value to H<sub>2</sub> at all concentrations when applying the power of 80 mW, suggesting that the  
6 temperature of this sensor, of around 241°C, is the optimal working temperature. The response  
7 values of this sensor were 2.1, 3.4, 4.5 and 8.2 at 25, 50, 100 and 250 ppm H<sub>2</sub>, respectively. The  
8 responses of this sensor, as shown in [Figure S3 \(Supplementary\)](#), increase almost linearly with  
9 the H<sub>2</sub> concentrations in the measured range, which is an advantage for the actual application in  
10 designing a sensor instrument [41,42].

11 To correlate the exact temperature of each sensor in the array, the hydrogen sensing  
12 characteristics of the sensor S2 was tested by using an external heater that generated  
13 temperatures from 50 to 350 °C with a step of 50 °C against the same H<sub>2</sub> concentrations as  
14 before (25–250 ppm). It was interesting to see that the sensor S2 showed superior sensitivity  
15 when using external heater compared with that when using the built-in microheater, as shown in  
16 Figure 6(C). The sensor S2 exhibited the maximum response value of XXX at a working  
17 temperature of 200°C, compared with the maximum response value of YYY at 241 °C when  
18 using the built-in **microheater** at the applied power of 80 mW and measuring with the IR  
19 microscope. Notably, this temperature value is much lower than that in the other reports on H<sub>2</sub>  
20 sensors based on SnO<sub>2</sub> disks [43] or Pt-SnO<sub>2</sub> nanoparticles [[10.1016/j.jallcom.2019.07.081](#)]. In  
21 addition, the fabricated sensor also exhibited superior sensitivity if it is noted that a gas sensor  
22 based on a Pd thin film exhibited a low response value of 4% to 4000 ppm of H<sub>2</sub> at 400°C [44].  
23 The higher response values of the sensor S2 when using the external heater and exposing to the



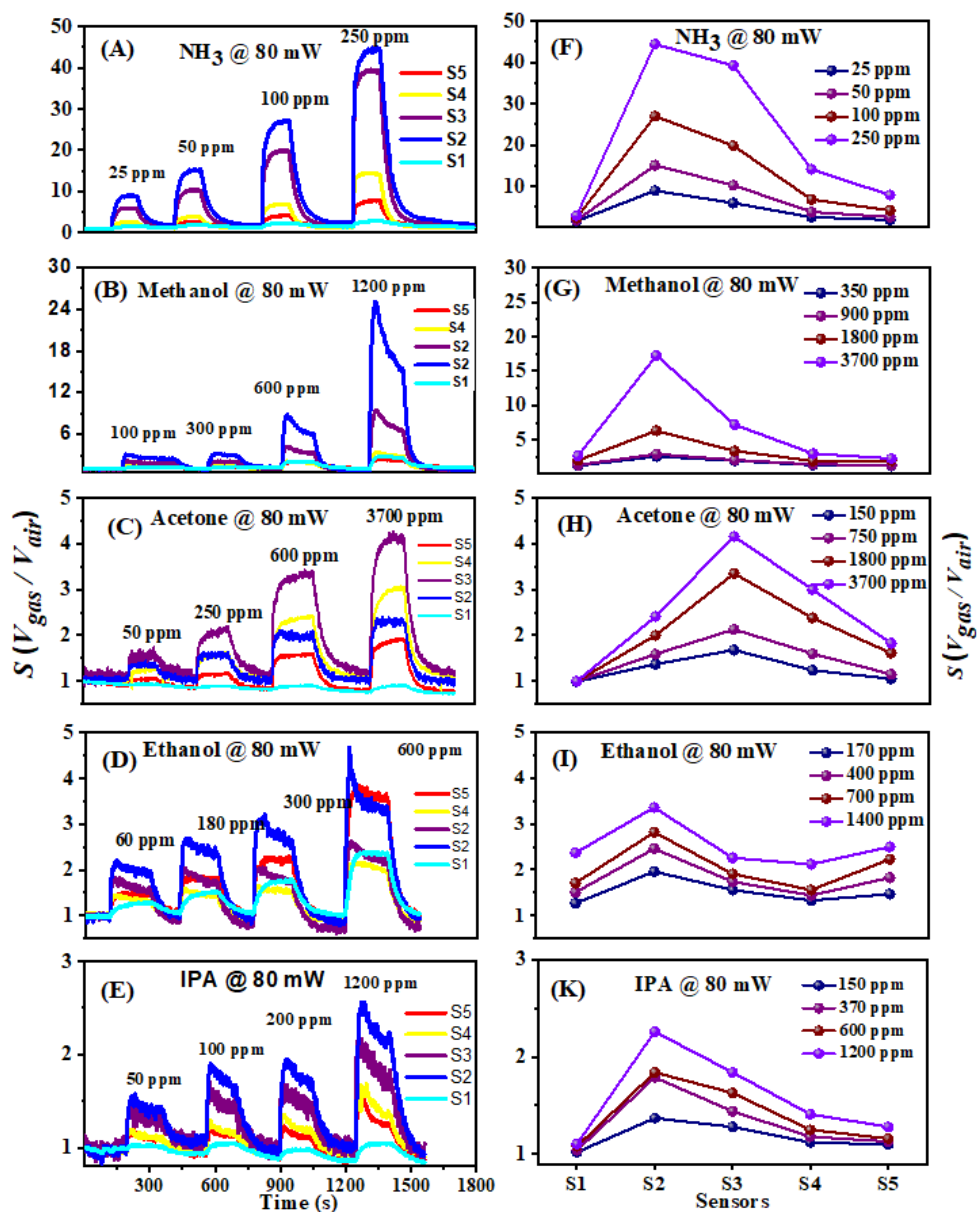
1 same range of gas concentration can be explained by the fact that the thermal energy of the  
2 external heater (actually a hot plate) is sufficient to pre-activate the gas in the sensor ambient  
3 triggering it to react with the pre-absorbed oxygen species.

4 The repeatability of the sensor performance is important for any application; therefore the short-  
5 term stability of the sensor was tested during six consecutive exposures to  $H_2$  and back to air, as  
6 shown in Figure 6(D). As seen here, the sensor array exhibited good repeatability without any  
7 significant change in the response values.



8  
9 **Figure 6.** (A) Transient response-recovery characteristics to periodic exposure to  $H_2$  (25–250  
10 ppm) at the power of 80 mW; (B) correspondent sensor response; (C) sensor response measured  
11 at different temperatures using an external heater; (D) repeatability of the five sensors on the  
12 detection of 50 ppm of  $H_2$  at 80 mW.

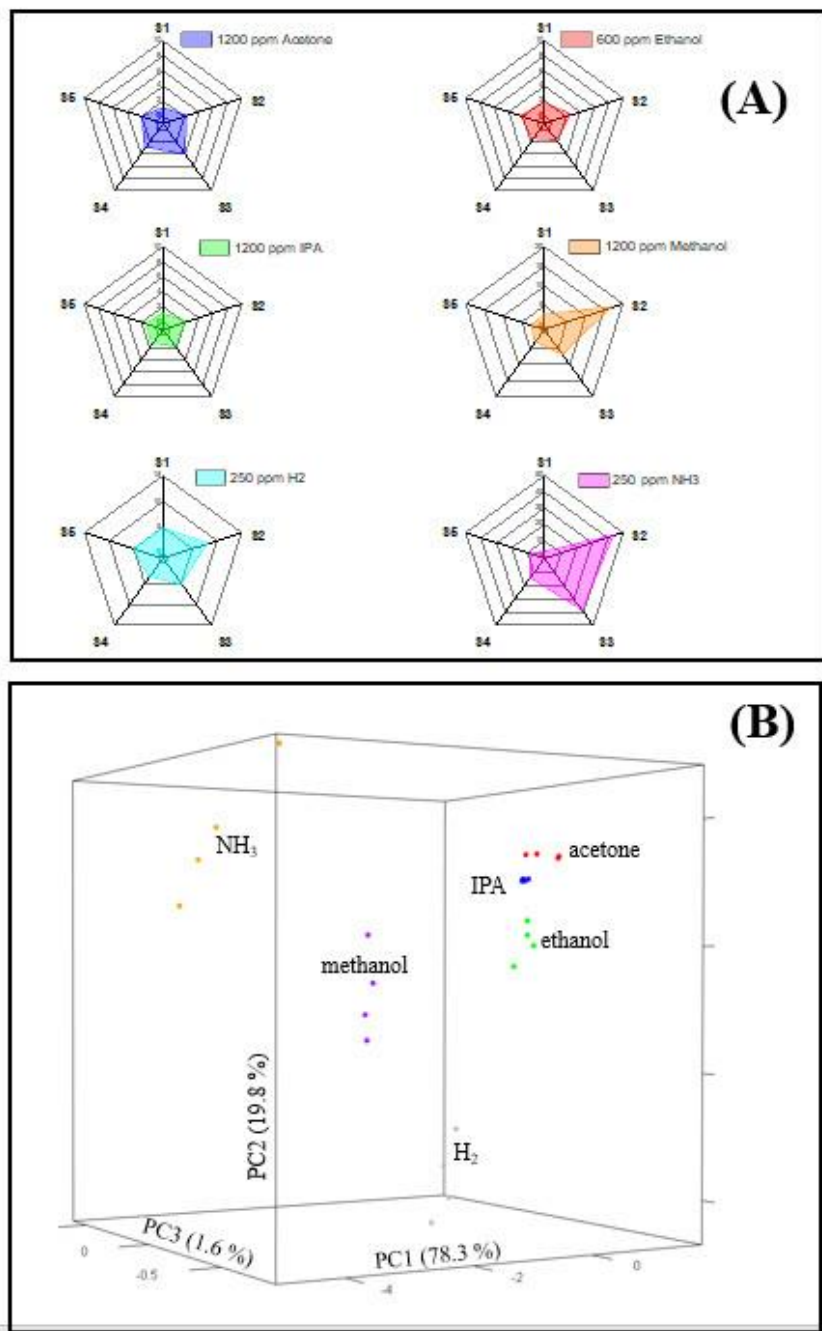
1 The gas sensing characteristics of the sensor array at the applied power of 80 mW were tested  
2 then against various gases, including ammonia (NH<sub>3</sub>), methanol, acetone, ethanol and iso-  
3 propanol (IPA). The transient response-recovery characteristics of the fabricated sensors to the  
4 gases are shown in Figure 7(A–E). Figure 7(A) shows the dynamic responses of the five sensors  
5 to NH<sub>3</sub> with concentrations of 20, 50, 100, and 250 ppm. Like for H<sub>2</sub>, the response values here  
6 also increase as the concentration of the test gas increases. For a given NH<sub>3</sub> concentration the  
7 response value was different for each sensor. The response plots of the five sensors to different  
8 NH<sub>3</sub> concentrations are shown in Figure 7(F). The sensor S2 has the highest response value  
9 compared with the others sensors at all gas concentrations, confirming that 241 °C is also the  
10 optimal working temperature for detection of NH<sub>3</sub>. The response values of the sensor S2 are 9.2,  
11 14.9, 27.1 and 44.3 at 25, 50, 100 and 250 ppm NH<sub>3</sub>, respectively. These results demonstrate that  
12 the microheater designed for the five sensors is effective for covering an adequate working  
13 temperature range. Similar response characteristics of the sensors were obtained when tested  
14 against methanol, acetone, ethanol and IPA (Figure 7(B–E) and (G–K)). Sensor S2, again,  
15 showed the highest response value among the five sensors to all tested gases, with an exception  
16 of acetone, to which the S3 sensor exhibited the highest response. This means that the optimal  
17 working temperature for detection of acetone is 293 °C. The responses of the five sensors (right  
18 column of Fig. 7) show clearly that the trend is different for each gas, and this demonstrates that  
19 the sensor array design is effective for classification of the tested gases. Notably, in this sensor  
20 array design, heat sinks are used between the microheater segments so that each sensor has its  
21 own heat source arranged in the desired temperature gradient. Compared with the sensor array  
22 designed with a single heat source in a previous report [31], the design in this work is better in  
23 respect of easy determining positions of the sensors and distances between them.



1  
 2 **Figure 7.** Gas sensing characteristics of the sensors S1–S5 at the applied power of 80 mW:  
 3 transient response-recovery characteristics upon periodic exposure of (A) NH<sub>3</sub>, (B) Methanol,  
 4 (C) Acetone, (D) Ethanol and (E) Iso-propanol; and plots of responses ( $S$ ) to different  
 5 concentrations of (F) NH<sub>3</sub>, (G) Methanol, (H) Acetone, (I) Ethanol and (K) Iso-propanol

1 The so called radar plot is effective for classification of different gases using an array of sensors  
2 [45]. In this study, the five sensors are fabricated in the same process steps with the same  
3 SnO<sub>2</sub>/Pt sensing material. They are arranged in such an array that allows them to work at  
4 different pre-determined temperatures. This design enables the sensor to respond selectively to  
5 different gases. The radar plot showing their selectivity is presented in Figure 8 (A). The shape  
6 and size of the graphs are different for each gas, confirming the capability of the sensor array to  
7 be used for classification of different gases. Notably, the size and shape of the radar plots for  
8 sensing methanol, hydrogen and ammonia here are very different, and the concentration of  
9 hydrogen, ammonia and ethanol is much lower than that of the other gases. However, the plots  
10 are different and distinguishable for the six gases. It is worthwhile to know that in the study  
11 reported by Lee et al. [46], an array of 3x3 sensors based on WO<sub>3</sub>, SnO<sub>2</sub>, and NiO decorated with  
12 Au nanoparticles was used for the detection and classification of acetone, toluene, ammonia and  
13 hydrogen sulfide by principal component analysis, where the temperature was varied to 150, 200,  
14 250, and 300 °C. To highlight the relationships between the sensing results of the gases, the  
15 principal component analysis (PCA) method is also used here, as shown in Figure 8(B). The  
16 clear positions and distances that separate the groups of points relating to the individual gases  
17 strengthen the classification results in the radar plots, namely ammonia is the most  
18 distinguishable, followed by H<sub>2</sub> and methanol. Acetone, ethanol and IPA, although  
19 distinguishable, are more similar to each other.

20



1

2 **Figure 8.** (A) Radar plot for the six tested gases (methanol, IPA, ethanol, NH<sub>3</sub>, H<sub>2</sub>S, H<sub>2</sub>) at the  
 3 applied power of 80 mW, and (B) gas classification by PCA method

4

1        **4. Conclusion**

2        A design and fabrication of SnO<sub>2</sub>/Pt thin film sensor array for effective detection and  
3        classification of multiple gases was presented. The sensor array consisting of five sensors on a  
4        chip was simulated by using COMSOL Multiphysics to obtain the desired temperature gradient  
5        and the chip was fabricated by using conventional photolithography, deposition and lift-off  
6        technique. The microheater and the five sensor electrodes of Pt/Cr thin films were fabricated  
7        simultaneously in the same process, followed by deposition of the same sensing material of  
8        SnO<sub>2</sub>/Pt thin films for the five sensors. The identical sensors were arranged in a temperature  
9        gradient of 190, 241, 293, 345 and 398 °C at an applied power of 80 mW. By using radar plots  
10       and the PCA, it was possible to analyze the measurement data from the five sensors to classify  
11       different gases. The developed sensor array with small size, high rapidity, stability, portability,  
12       and robustness demonstrated its strong candidacy to using in real gas measurement instruments  
13       and electronic noses.

14

15       **Conflict of Interests**

16       The authors declare that there is no conflict of interests regarding the publication of this paper.

17       **Acknowledgment**

18       This research is funded by the Vietnamese Ministry of Science and Technology under the grant  
19       number NĐT/KR/21/20

20       **References**

- 1 [1] L. Van Duy, N. Van Duy, C.M. Hung, N.D. Hoa, N.Q. Dich, Urea mediated synthesis and  
2 acetone-sensing properties of ultrathin porous ZnO nanoplates, *Mater. Today Commun.*  
3 25 (2020) 101445. doi:10.1016/j.mtcomm.2020.101445.
- 4 [2] R.A. Potyrailo, S. Go, D. Sexton, X. Li, N. Alkadi, A. Kolmakov, B. Amm, R. St-Pierre,  
5 B. Scherer, M. Nayeri, G. Wu, C. Collazo-Davila, D. Forman, C. Calvert, C. Mack, P.  
6 McConnell, Extraordinary performance of semiconducting metal oxide gas sensors using  
7 dielectric excitation, *Nat. Electron.* 3 (2020) 280–289. doi:10.1038/s41928-020-0402-3.
- 8 [3] G.W. Hunter, S. Akbar, S. Bhansali, M. Daniele, P.D. Erb, K. Johnson, C.-C. Liu, D.  
9 Miller, O. Oralkan, P.J. Hesketh, P. Manickam, R.L. Vander Wal, Editors' Choice—  
10 Critical Review—A Critical Review of Solid State Gas Sensors, *J. Electrochem. Soc.* 167  
11 (2020) 37570. doi:10.1149/1945-7111/ab729c.
- 12 [4] C.M. Hung, D.Q. Dat, N. Van Duy, V. Van Quang, N. Van Toan, N. Van Hieu, N.D. Hoa,  
13 Facile synthesis of ultrafine rGO/WO<sub>3</sub> nanowire nanocomposites for highly sensitive  
14 toxic NH<sub>3</sub> gas sensors, *Mater. Res. Bull.* 125 (2020) 110810.  
15 doi:10.1016/j.materresbull.2020.110810.
- 16 [5] N.H. Hanh, L. Van Duy, C.M. Hung, N. Van Duy, Y.-W. Heo, N. Van Hieu, N.D. Hoa,  
17 VOC gas sensor based on hollow cubic assembled nanocrystal Zn<sub>2</sub>SnO<sub>4</sub> for breath  
18 analysis, *Sensors Actuators A Phys.* 302 (2020) 111834. doi:10.1016/j.sna.2020.111834.
- 19 [6] J.-W. Yoon, J.-H. Lee, Toward breath analysis on a chip for disease diagnosis using  
20 semiconductor-based chemiresistors: recent progress and future perspectives, *Lab Chip.*  
21 17 (2017) 3537–3557. doi:10.1039/C7LC00810D.
- 22 [7] S. Su, J. Hu, Gas Identification by a Single Metal-Oxide-Semiconductor Sensor Assisted  
23 by Ultrasound, *ACS Sensors.* 4 (2019) 2491–2496. doi:10.1021/acssensors.9b01113.
- 24 [8] D. Karakaya, O. Ulucan, M. Turkan, Electronic Nose and Its Applications: A Survey, *Int.*  
25 *J. Autom. Comput.* 17 (2020) 179–209. doi:10.1007/s11633-019-1212-9.
- 26 [9] J. van den Broek, D. Bischof, N. Derron, S. Abegg, P.A. Gerber, A.T. Güntner, S.E.  
27 Pratsinis, Screening Methanol Poisoning with a Portable Breath Detector, *Anal. Chem.* 93  
28 (2021) 1170–1178. doi:10.1021/acs.analchem.0c04230.
- 29 [10] R. Fend, A.H.J. Kolk, C. Bessant, P. Buijtelts, P.R. Klatser, A.C. Woodman, Prospects for  
30 Clinical Application of Electronic-Nose Technology to Early Detection of Mycobacterium  
31 tuberculosis in Culture and Sputum, *J. Clin. Microbiol.* 44 (2006) 2039–2045.  
32 doi:10.1128/JCM.01591-05.
- 33 [11] Y. Zhang, J. Zhao, T. Du, Z. Zhu, J. Zhang, Q. Liu, A gas sensor array for the  
34 simultaneous detection of multiple VOCs, *Sci. Rep.* 7 (2017) 1960. doi:10.1038/s41598-  
35 017-02150-z.
- 36 [12] Z. Chen, Z. Chen, Z. Song, W. Ye, Z. Fan, Smart gas sensor arrays powered by artificial  
37 intelligence, *J. Semicond.* 40 (2019) 111601. doi:10.1088/1674-4926/40/11/111601.
- 38 [13] A.T. Güntner, V. Koren, K. Chikkadi, M. Righettoni, S.E. Pratsinis, E-Nose Sensing of

- 1 Low-ppb Formaldehyde in Gas Mixtures at High Relative Humidity for Breath Screening  
2 of Lung Cancer?, ACS Sensors. 1 (2016) 528–535. doi:10.1021/acssensors.6b00008.
- 3 [14] J. Zhang, Y. Xue, Q. Sun, T. Zhang, Y. Chen, W. Yu, Y. Xiong, X. Wei, G. Yu, H. Wan,  
4 P. Wang, A miniaturized electronic nose with artificial neural network for anti-  
5 interference detection of mixed indoor hazardous gases, Sensors Actuators B Chem. 326  
6 (2021) 128822. doi:10.1016/j.snb.2020.128822.
- 7 [15] W. Li, H. Liu, D. Xie, Z. He, X. Pi, Lung Cancer Screening Based on Type-different  
8 Sensor Arrays, Sci. Rep. 7 (2017) 1969. doi:10.1038/s41598-017-02154-9.
- 9 [16] D. Drix, M. Schmuker, Resolving Fast Gas Transients with Metal Oxide Sensors, ACS  
10 Sensors. 6 (2021) 688–692. doi:10.1021/acssensors.0c02006.
- 11 [17] D. Feng, L. Du, X. Xing, C. Wang, J. Chen, Z. Zhu, Y. Tian, D. Yang, Highly Sensitive  
12 and Selective NiO/WO<sub>3</sub> Composite Nanoparticles in Detecting H<sub>2</sub>S Biomarker of  
13 Halitosis, ACS Sensors. 6 (2021) 733–741. doi:10.1021/acssensors.0c01280.
- 14 [18] G. Sakai, N. Matsunaga, K. Shimano, N. Yamazoe, Theory of gas-diffusion controlled  
15 sensitivity for thin film semiconductor gas sensor, Sensors Actuators B Chem. 80 (2001)  
16 125–131. doi:10.1016/S0925-4005(01)00890-5.
- 17 [19] N. Bârsan, A. Tomescu, The temperature dependence of the response of SnO<sub>2</sub>-based gas  
18 sensing layers to O<sub>2</sub>, CH<sub>4</sub> and CO, Sensors Actuators B Chem. 26 (1995) 45–48.  
19 doi:10.1016/0925-4005(94)01553-T.
- 20 [20] V. V. Sysoev, E. Strelcov, M. Sommer, M. Bruns, I. Kiselev, W. Habicht, S. Kar, L.  
21 Gregoratti, M. Kiskinova, A. Kolmakov, Single-Nanobelt Electronic Nose: Engineering  
22 and Tests of the Simplest Analytical Element, ACS Nano. 4 (2010) 4487–4494.  
23 doi:10.1021/nn100435h.
- 24 [21] M. Tonezzer, J.-H. Kim, J.-H. Lee, S. Iannotta, S.S. Kim, Predictive gas sensor based on  
25 thermal fingerprints from Pt-SnO<sub>2</sub> nanowires, Sensors Actuators B Chem. 281 (2019)  
26 670–678. doi:10.1016/j.snb.2018.10.102.
- 27 [22] J.M. Baik, M. Zielke, M.H. Kim, K.L. Turner, A.M. Wodtke, M. Moskovits, Tin-Oxide-  
28 Nanowire-Based Electronic Nose Using Heterogeneous Catalysis as a Functionalization  
29 Strategy, ACS Nano. 4 (2010) 3117–3122. doi:10.1021/nn100394a.
- 30 [23] C. Wongchoosuk, K. Subannajui, C. Wang, Y. Yang, F. Güder, T. Kerdcharoen, V.  
31 Cimalla, M. Zacharias, Electronic nose for toxic gas detection based on photostimulated  
32 core–shell nanowires, RSC Adv. 4 (2014) 35084–35088. doi:10.1039/C4RA06143H.
- 33 [24] V. Sysoev, I. Kiselev, M. Frietsch, J. Goschnick, Temperature Gradient Effect on Gas  
34 Discrimination Power of a Metal-Oxide Thin-Film Sensor Microarray, Sensors. 4 (2004)  
35 37–46. doi:10.3390/s40400037.
- 36 [25] and A.K. Victor V. Sysoev, Joachim Goschnick, Thomas Schneider, Evghenii Strelcov, A  
37 Gradient Microarray Electronic Nose Based on Percolating SnO<sub>2</sub> Nanowire Sensing  
38 Elements, Nano Lett. 2007, 7, 10, 3182–3188. (n.d.). doi:10.1021/nl071815+.



- 1 [26] S.Y. Park, Y. Kim, T. Kim, T.H. Eom, S.Y. Kim, H.W. Jang, Chemoresistive materials for  
2 electronic nose: Progress, perspectives, and challenges, *InfoMat*. 1 (2019) 289–316.  
3 doi:10.1002/inf2.12029.
- 4 [27] Y. Chen, M. Li, W. Yan, X. Zhuang, K.W. Ng, X. Cheng, Sensitive and Low-Power  
5 Metal Oxide Gas Sensors with a Low-Cost Microelectromechanical Heater, *ACS Omega*.  
6 6 (2021) 1216–1222. doi:10.1021/acsomega.0c04340.
- 7 [28] P. Acuña-Avila, R. Calavia, E. Viguera-Santiago, E. Llobet, Identification of Tequila  
8 with an Array of ZnO Thin Films: A Simple and Cost-Effective Method, *Sensors*. 17  
9 (2017) 2943. doi:10.3390/s17122943.
- 10 [29] N. Van Toan, C.M. Hung, N. Van Duy, N.D. Hoa, D.T.T. Le, N. Van Hieu, Bilayer  
11 SnO<sub>2</sub>–WO<sub>3</sub> nanofilms for enhanced NH<sub>3</sub> gas sensing performance, *Mater. Sci. Eng. B*.  
12 224 (2017) 163–170. doi:10.1016/j.mseb.2017.08.004.
- 13 [30] N.X. Thai, N. Van Duy, N. Van Toan, C.M. Hung, N. Van Hieu, N.D. Hoa, Effective  
14 monitoring and classification of hydrogen and ammonia gases with a bilayer Pt/SnO<sub>2</sub> thin  
15 film sensor, *Int. J. Hydrogen Energy*. 45 (2020) 2418–2428.  
16 doi:10.1016/j.ijhydene.2019.11.072.
- 17 [31] N.X. Thai, N. Van Duy, C.M. Hung, H. Nguyen, M. Tonezzer, N. Van Hieu, N.D. Hoa,  
18 Prototype edge-grown nanowire sensor array for the real-time monitoring and  
19 classification of multiple gases, *J. Sci. Adv. Mater. Devices*. 5 (2020) 409–416.  
20 doi:10.1016/j.jsamd.2020.05.005.
- 21 [32] S. Chen, L. Shi, L. Wang, Mesoporous PtSnO<sub>2</sub>/C Catalyst with Enhanced Catalytic  
22 Activity for Ethanol Electro-oxidation, *Kem. U Ind.* 67 (2018) 19–27.  
23 doi:10.15255/KUI.2017.028.
- 24 [33] N. Van Duy, N.D. Hoa, N. Van Hieu, Effective hydrogen gas nanosensor based on bead-  
25 like nanowires of platinum-decorated tin oxide, *Sensors Actuators B Chem.* 173 (2012)  
26 211–217. doi:10.1016/j.snb.2012.06.079.
- 27 [34] N. Van Toan, N. Viet Chien, N. Van Duy, H. Si Hong, H. Nguyen, N. Duc Hoa, N. Van  
28 Hieu, Fabrication of highly sensitive and selective H<sub>2</sub> gas sensor based on SnO<sub>2</sub> thin  
29 film sensitized with micro-sized Pd islands, *J. Hazard. Mater.* 301 (2016) 433–442.  
30 doi:10.1016/j.jhazmat.2015.09.013.
- 31 [35] N.D. Hoa, N. Van Quy, D. Kim, Nanowire structured SnO<sub>x</sub>–SWNT composites: High  
32 performance sensor for NO<sub>x</sub> detection, *Sensors Actuators B Chem.* 142 (2009) 253–259.  
33 doi:10.1016/j.snb.2009.07.053.
- 34 [36] L. Yang, X. Zhou, L. Song, Y. Wang, X. Wu, N. Han, Y. Chen, Noble Metal/Tin Dioxide  
35 Hierarchical Hollow Spheres for Low-Concentration Breath Methane Sensing, *ACS Appl.*  
36 *Nano Mater.* 1 (2018) 6327–6336. doi:10.1021/acsnm.8b01529.
- 37 [37] L.S. Kibis, D.A. Svintsitskiy, A.I. Stadnichenko, E.M. Slavinskaya, A. V. Romanenko,  
38 E.A. Fedorova, O.A. Stonkus, V.A. Svetlichnyi, E.D. Fakhrutdinova, M. Vorokhta, B.

- 1 Šmíd, D.E. Doronkin, V. Marchuk, J.-D. Grunwaldt, A.I. Boronin, In situ probing of  
2 Pt/TiO<sub>2</sub> activity in low-temperature ammonia oxidation, *Catal. Sci. Technol.* 11 (2021)  
3 250–263. doi:10.1039/D0CY01533D.
- 4 [38] M. Liu, W. Tang, Z. Xie, H. Yu, H. Yin, Y. Xu, S. Zhao, S. Zhou, Design of Highly  
5 Efficient Pt-SnO<sub>2</sub> Hydrogenation Nanocatalysts using Pt@Sn Core–Shell Nanoparticles,  
6 *ACS Catal.* 7 (2017) 1583–1591. doi:10.1021/acscatal.6b03109.
- 7 [39] D. Ma, J. Gao, Z. Zhang, H. Zhao, Gas recognition method based on the deep learning  
8 model of sensor array response map, *Sensors Actuators B Chem.* 330 (2021) 129349.  
9 doi:10.1016/j.snb.2020.129349.
- 10 [40] J. Kang, J.-S. Park, H.-J. Lee, Pt-doped SnO<sub>2</sub> thin film based micro gas sensors with high  
11 selectivity to toluene and HCHO, *Sensors Actuators B Chem.* 248 (2017) 1011–1016.  
12 doi:10.1016/j.snb.2017.03.010.
- 13 [41] N. Van Toan, C.M. Hung, N.D. Hoa, N. Van Duy, D. Thi Thanh Le, N. Thi Thu Hoa,  
14 N.N. Viet, P.H. Phuoc, N. Van Hieu, Enhanced NH<sub>3</sub> and H<sub>2</sub> gas sensing with H<sub>2</sub>S gas  
15 interference using multilayer SnO<sub>2</sub>/Pt/WO<sub>3</sub> nanofilms, *J. Hazard. Mater.* 412 (2021)  
16 125181. doi:10.1016/j.jhazmat.2021.125181.
- 17 [42] N.X. Thai, N. Van Duy, C.M. Hung, H. Nguyen, T.M. Hung, N. Van Hieu, N.D. Hoa,  
18 Realization of a portable H<sub>2</sub>S sensing instrument based on SnO<sub>2</sub> nanowires, *J. Sci. Adv.  
19 Mater. Devices.* 5 (2020) 40–47. doi:10.1016/j.jsamd.2020.01.003.
- 20 [43] A. Umar, H.Y. Ammar, R. Kumar, T. Almas, A.A. Ibrahim, M.S. AlAssiri, M. Abaker, S.  
21 Baskoutas, Efficient H<sub>2</sub> gas sensor based on 2D SnO<sub>2</sub> disks: Experimental and theoretical  
22 studies, *Int. J. Hydrogen Energy.* 45 (2020) 26388–26401.  
23 doi:10.1016/j.ijhydene.2019.04.269.
- 24 [44] Q. Liu, J. Yao, Y. Wu, Y. Wang, G. Ding, Two operating modes of palladium film  
25 hydrogen sensor based on suspended micro hotplate, *Int. J. Hydrogen Energy.* 44 (2019)  
26 11259–11265. doi:10.1016/j.ijhydene.2019.02.228.
- 27 [45] M. Abdelkhalek, S. Alfayad, F. Benouezdou, M.B. Fayek, L. Chassagne, Compact and  
28 Embedded Electronic Nose for Volatile and Non-Volatile Odor Classification for Robot  
29 Applications, *IEEE Access.* 7 (2019) 98267–98276. doi:10.1109/ACCESS.2019.2928875.
- 30 [46] J. Lee, Y. Jung, S.-H. Sung, G. Lee, J. Kim, J. Seong, Y.-S. Shim, S.C. Jun, S. Jeon, High-  
31 performance gas sensor array for indoor air quality monitoring: the role of Au  
32 nanoparticles on WO<sub>3</sub>, SnO<sub>2</sub>, and NiO-based gas sensors, *J. Mater. Chem. A.* 9 (2021)  
33 1159–1167. doi:10.1039/D0TA08743B.

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